

## Electronic Acknowledgement Receipt

<b>EFS ID:</b>	2491167
<b>Application Number:</b>	10689617
<b>International Application Number:</b>	
<b>Confirmation Number:</b>	4799
<b>Title of Invention:</b>	Method for cleaning plasma etching apparatus, method for plasma etching, and method for manufacturing semiconductor device
<b>First Named Inventor/Applicant Name:</b>	Satoru Okamoto
<b>Customer Number:</b>	26171
<b>Filer:</b>	Diana DiBerardino/Arlene Yates
<b>Filer Authorized By:</b>	Diana DiBerardino
<b>Attorney Docket Number:</b>	12732-170001
<b>Receipt Date:</b>	20-NOV-2007
<b>Filing Date:</b>	22-OCT-2003
<b>Time Stamp:</b>	12:28:52
<b>Application Type:</b>	Utility under 35 USC 111(a)

### Payment information:

Submitted with Payment	yes
Payment Type	Deposit Account
Payment was successfully received in RAM	\$180
RAM confirmation Number	8796
Deposit Account	061050
Authorized User	
The Director of the USPTO is hereby authorized to charge indicated fees and credit any overpayment as follows:	
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**File Listing:**

Document Number	Document Description	File Name	File Size(Bytes) /Message Digest	Multi Part /.zip	Pages (if appl.)
1	Information Disclosure Statement (IDS) Filed	12732170001IDS.pdf	338253 692b6e1cf73a8b837285ae1d383391a1 c0d347d4	no	3

**Warnings:****Information:**

This is not an USPTO supplied IDS fillable form

2		12732170001refs.pdf	3517729 7471941533365e907ca75c97dec1407 249fb5b3	yes	51
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**Multipart Description/PDF files in .zip description**

Document Description	Start	End
Foreign Reference	1	5
Foreign Reference	6	8
Foreign Reference	9	19
Foreign Reference	20	51

**Warnings:****Information:**

3	Fee Worksheet (PTO-06)	fee-info.pdf	8222 6ed4f670c1bd4fb6d2254293389eb89 2ad53e66	no	2
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**Warnings:****Information:**

<b>Total Files Size (in bytes):</b>	3864204
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**New Applications Under 35 U.S.C. 111**

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

**National Stage of an International Application under 35 U.S.C. 371**

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

**New International Application Filed with the USPTO as a Receiving Office**

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.